



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kim, et al.

Serial No.: 10/732,904

Filed: December 10, 2003

Confirmation No.: Unassigned

For: Nitrogen-Free Dielectric Anti-  
Reflective Coating and Hardmask

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

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Group Art Unit: Unassigned

Examiner: Unassigned

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>4/8</u> , 2004, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
<u>4/8/04</u> Date	<u>Keith M. Tackett</u> Signature

CLAIM TO PRIORITY

Applicants reaffirm the claim for priority of the following patent applications referred to in Applicant's Specification:

The application is a continuation in part of United States Application Serial Number 10/193,489 filed July 11, 2002, and claims priority to United States Application Serial Number 60/433,445 filed December 13, 2002, and United States Application Serial Number 60/526,259 filed December 1, 2003.

Respectfully submitted,

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